

Comparing Different Cross-Section Cutting Methods for SEM Analysis of Membrane-Electrodes Assemblies

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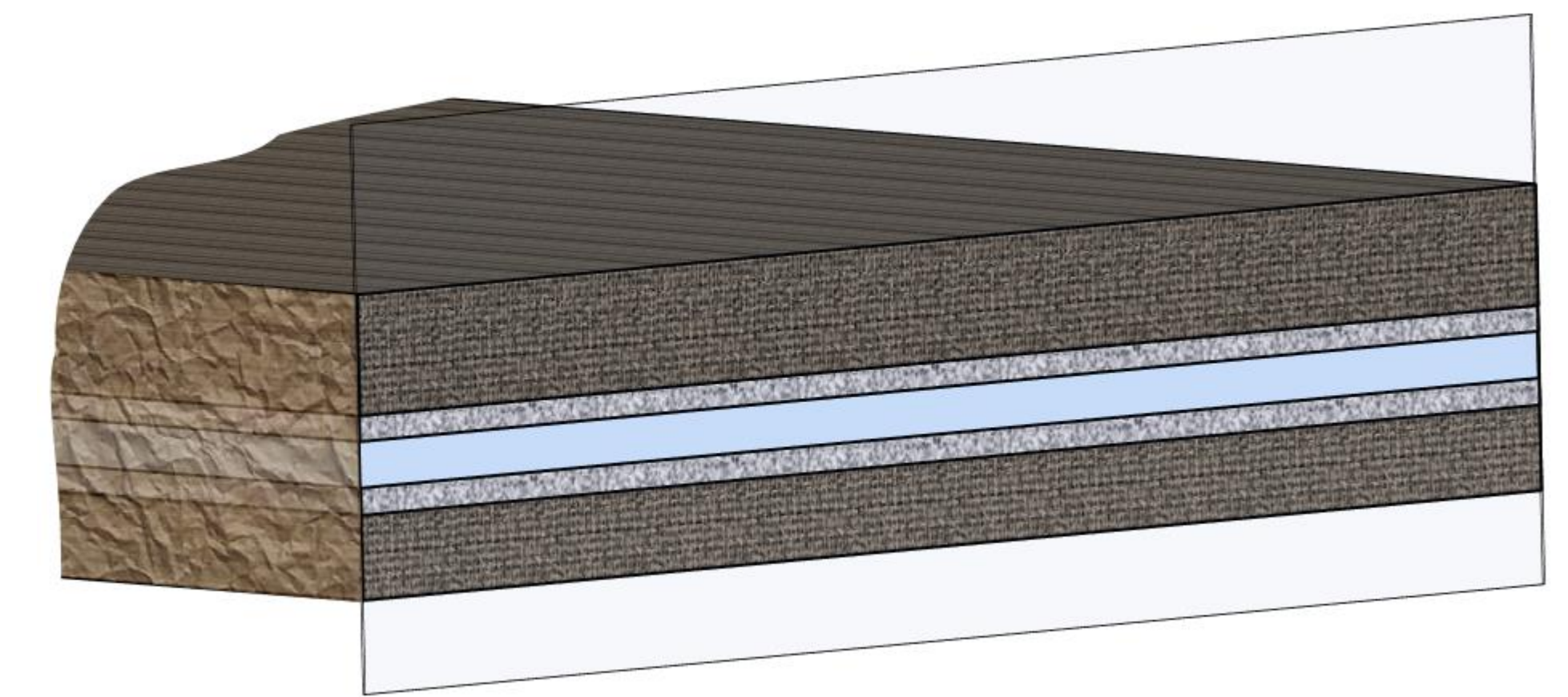
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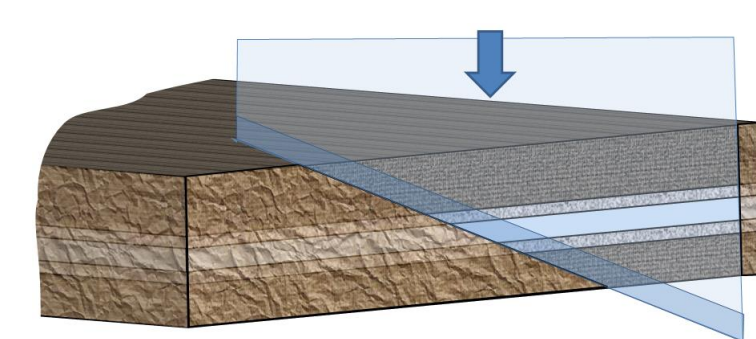
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The correct cross-sectional visualization of membrane-electrode assemblies (MEAs) with scanning electron microscopy (SEM) requires preparation of planes where the different phases can be distinguished with minimal modification of their morphology and thickness. Such preparation is complicated by the different mechanical properties of the layers of an MEA, including a plastic membrane, carbon cloths, and porous carbon layers like the catalyst layers and the microporous layers. This communication compares four techniques for the cutting of MEAs for cross sectional visualization with SEM: the sharp-edge cutting, CO₂ laser, embedded-mechanical polishing, and ion-milling. From the results of the cross section visualization of the MEAs, the methods are compared attending to reproducibility, phases thickness preservation, and phase morphology preservation.

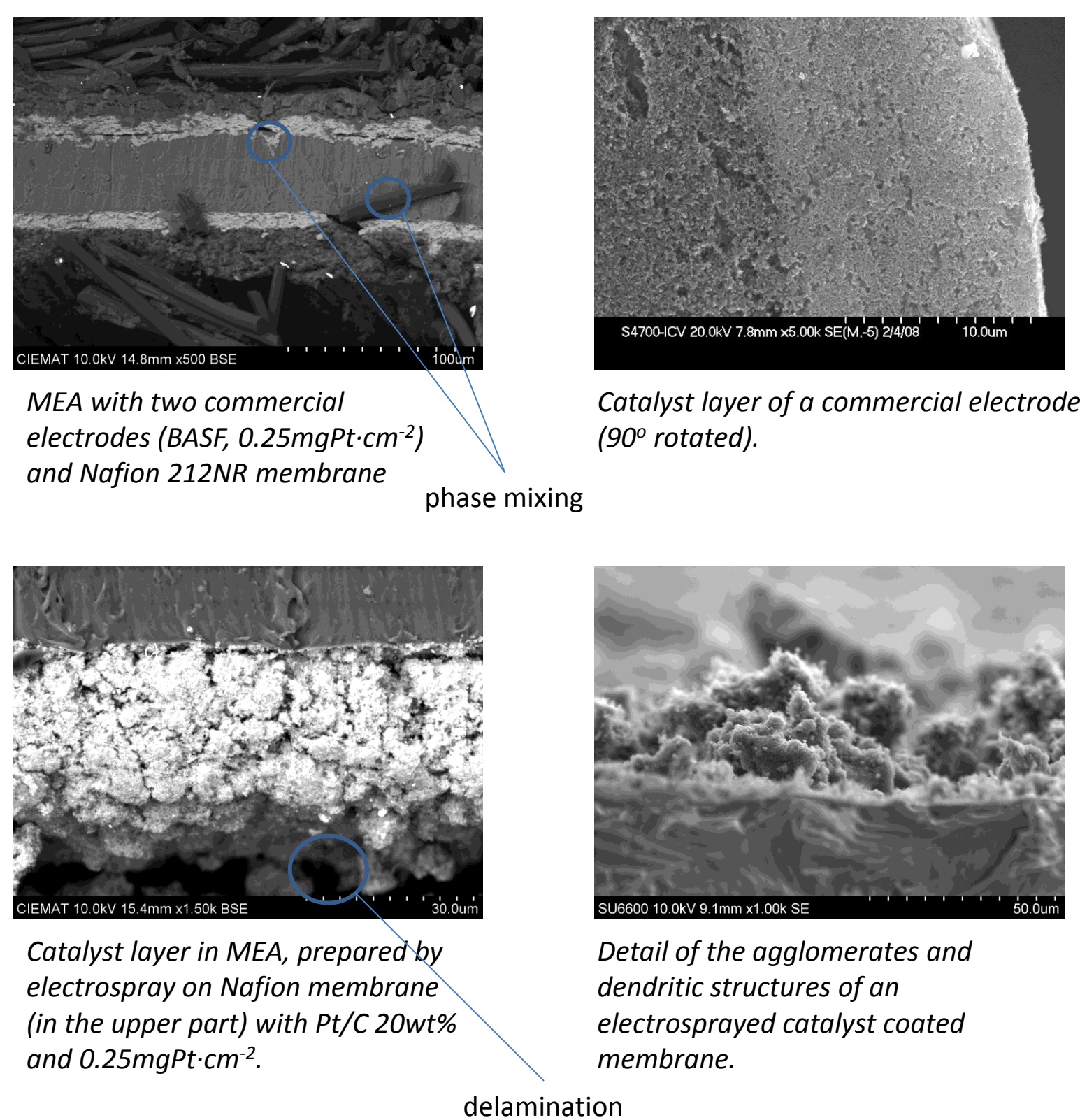
Experimental: MEAs prepared with Nafion NR212 membrane (Ion Power Inc.), and two types of commercial gas diffusion electrodes, BASF (ELAT GDE LT250EWALTSI, BASF, 0.25 mgPt-cm⁻²), and Fuel Cell ETC (0.3 mg/cm² 40% Platinum on Vulcan - Cloth GDE). Also electrodes with catalyst layers deposited by the electrospray technique were observed in cross-section. For SEM a Hitachi FE-SEM SU-6600 microscope was used.



Sharp-edge cutting



standard laboratory snap-off blade



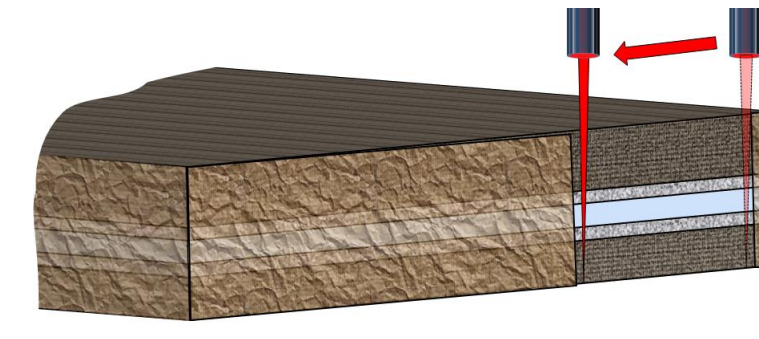
Advantages:

- Fast and low cost method
- May preserve the porous morphology of the layers rather unaltered

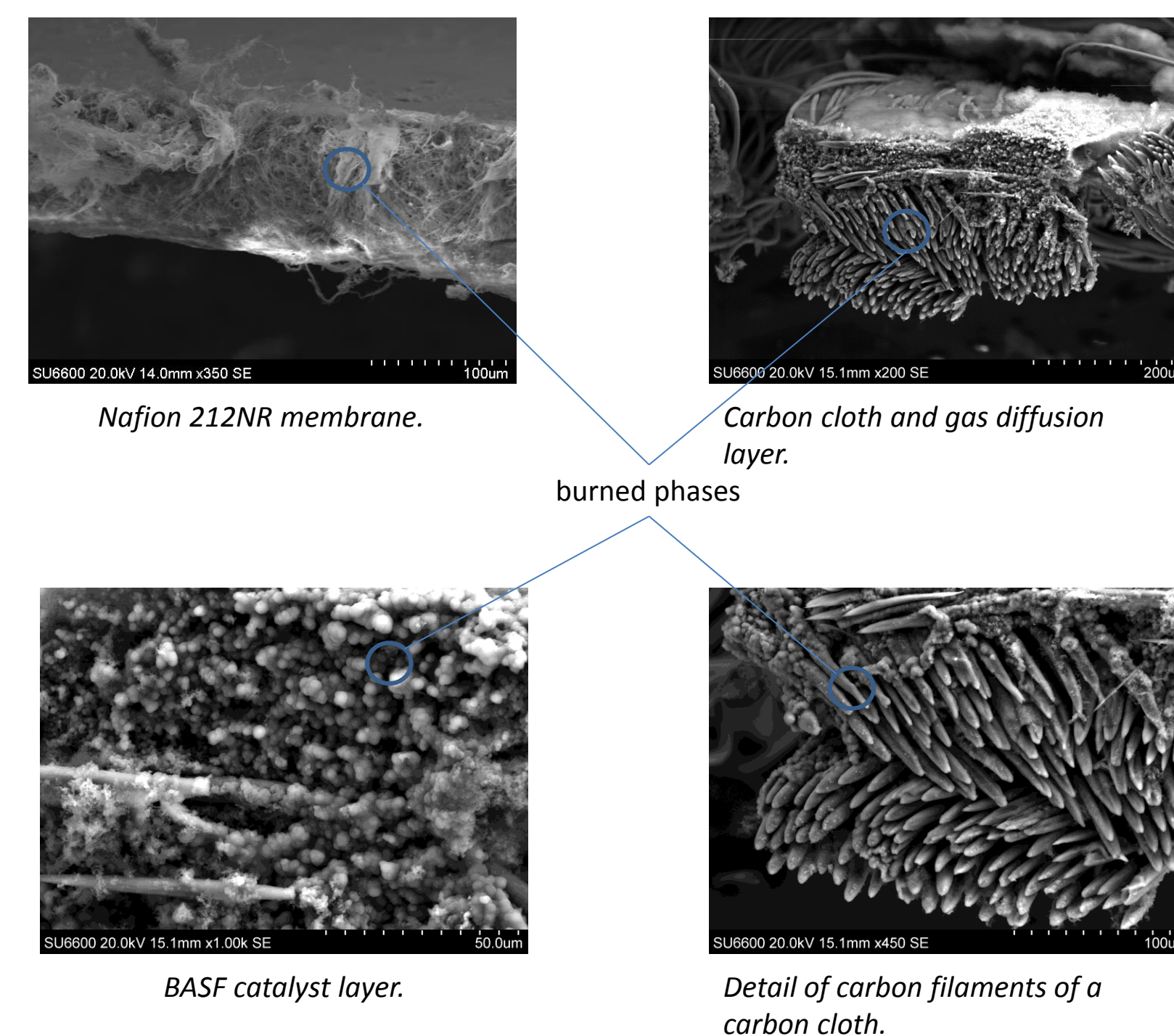
Disadvantages:

- Obtaining a good cross-section in a wide area is stochastic and with low probability.
- Frequent intermixing and delaminating of layers

CO₂ laser



laser cutting machine, Gravograph LS100, 35 W, 50-500DPI



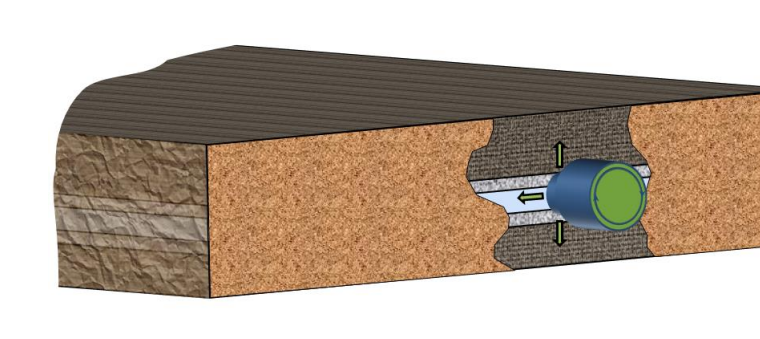
Advantages:

- Fast method, with automatic selection of the cutting line
- Commercially available machines at relatively low price

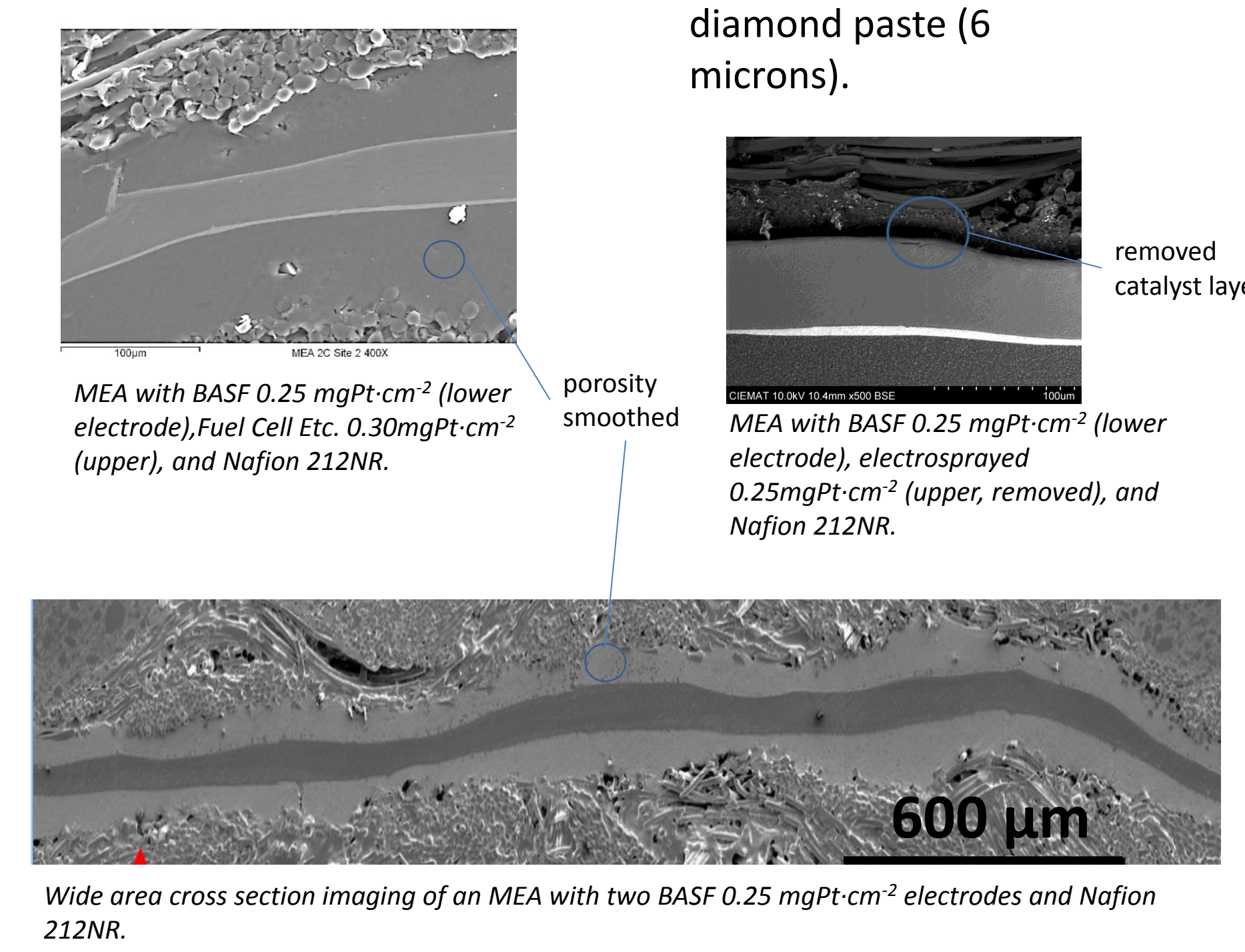
Disadvantages:

- Alters severely the microstructure of carbon and Nafion layers as a consequence of the burning of carbon based materials.

Embedded-mechanical polishing



Embedded in EPOMET® G resin, compression under 80 bar at 150 °C. Grinding with SiC papers (P320, P600, P1200) and water, and polishing with diamond paste (6 microns).



Advantages:

- Well established metallographic method
- Reproducible and accurate thickness of the layers

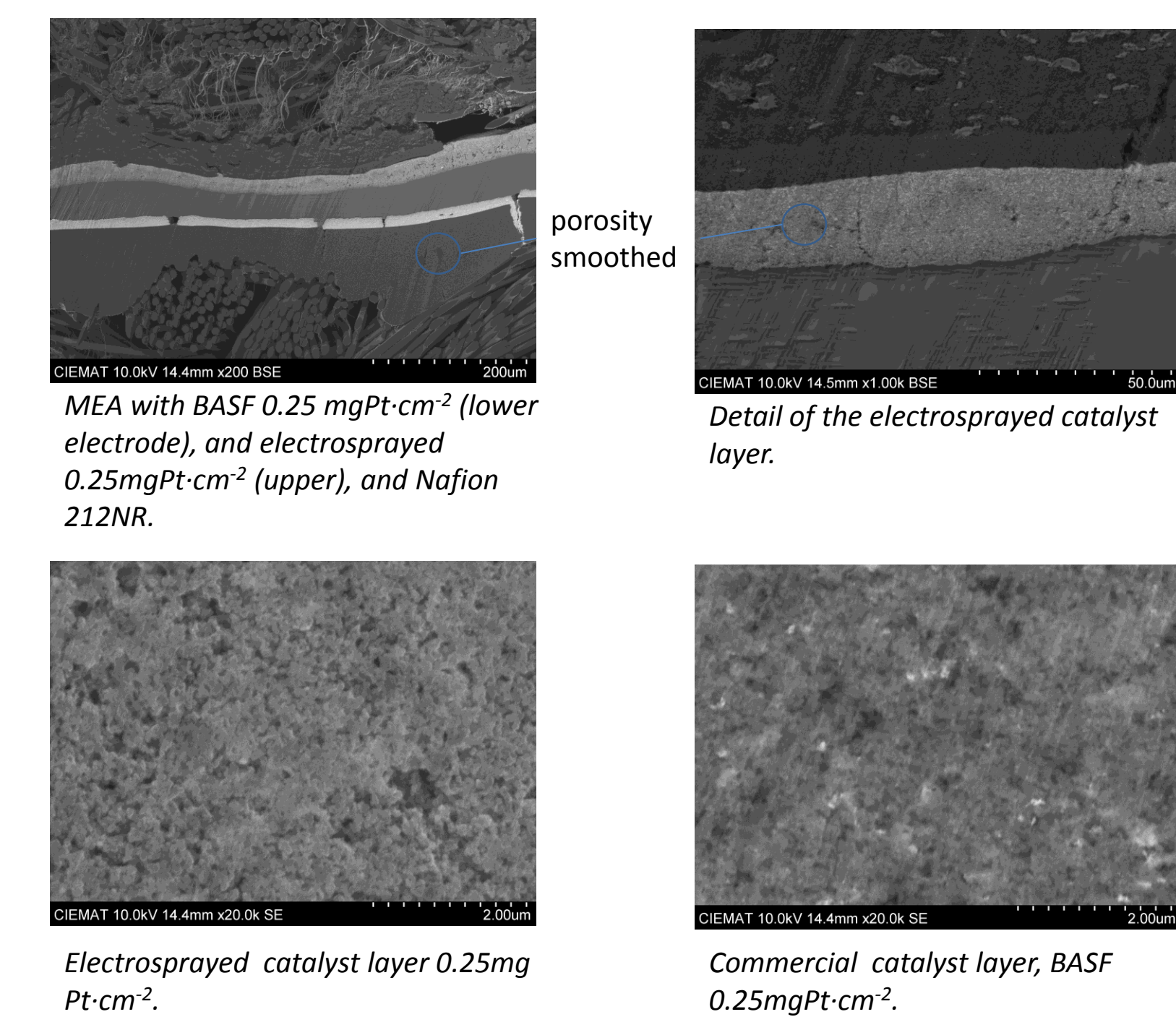
Disadvantages:

- Porous layers may appear smoothed or removed
- Time consuming preparation

Ion-milling



Hitachi High-Tech IM4000 system, using Argon beam with accelerating voltage of 5 kV during 6 h, using 2.3 reciprocation-min⁻¹ and a swing angle of ±40 °C. For catalyst coated membranes, the same conditions were used reducing the time to 3 h.



Advantages:

- Accurate and reproducible thicknesses measurements

Disadvantages:

- Smoothing morphologies
- Expensive machinery
- Time consuming preparation
- Short observation length (mm)

Conclusions

1. The four methods tested here for cross-sections preparation of MEAs show differences in thickness and morphology preservation of the samples.
2. For the analysis of porous morphologies, the sharp-edge cutting appears most adequate since it may leave rather unaltered porosities of the layers. However the method is stochastic and relies largely on the experience and skills.
3. For the analysis of the thickness of the layers, the embedding-polishing method and the ion-milling are more reliable and reproducible. However, both methods alter porous morphologies, yielding smoothing of porosities of the carbonaceous layers.
4. The ion-milling method is more conservative with the porosity than the embedding-polishing but it can only be applied to small, millimeter wide, areas of the MEA.
5. It is not discarded that the future optimization of all these methodologies may improve the shortcomings observed in this work.

Cutting Method	Reproducibility	Thickness preservation	Morphology preservation	Preparation time	Comments
Sharp edge	low	medium-low	high	minutes	Low cost, preserves porosity
CO ₂ laser	high	low	low	minutes	laser machine, alters morphologies
Embedding-polishing	high	high	low	2-3 hours	laborious, aggressive with soft material
Ion-milling	high	high	medium-low	4-5 hours	expensive equipment, short observation length (mm)